Docket No.: 065933-0084

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Ryosuke USUI, et al.

Confirmation Number: 3812

Application No.: 10/813,629

Group Art Unit: 2814

Filed: March 31, 2004

Examiner: Dilinh P. Nguyen

For: SEMICONDUCTOR MODULE AND METHOD OF MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

<u>CERTIFICATION PARAGRAPH</u>

10/813,629

The undersigned certifies that each item of information contained in this Information

Disclosure Statement was first cited in a communication from a foreign patent office in a

counterpart foreign application not more than three months prior to the filing of this Information

Disclosure Statement as described in 37 CFR 1.97(e)(1).

The reference was cited in a corresponding foreign office action and its relevance is

discussed therein. A copy of the foreign office action, together with an English language version

thereof, is attached for the Examiner's information. The reference JP 10-284648 was previously

submitted on January 31, 2006, and therefore, it is not attached.

Please charge any shortage in fees due in connection with the filing of this paper,

including extension of time fees, to Deposit Account 500417 and please credit any excess fees to

such deposit account.

Respectfully submitted,

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Date: November 29, 2006

Please recognize our Customer No. 20277 as our correspondence address.

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SHEET 1 OF 1

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					APPLICANT Ryosuke USUI, et al.						
(PTO-1449)					FILING DATE March 31, 2004	FILING DATE GROUP March 31, 2004 2814					
U.S. PATENT DOCUMENTS											
EXAMINER'S	CITE		Document Number	Publication Dat	e Name of Patentee or An	Name of Patentee or Applicant of Cited Pages, Columns, Lines, Where					
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FOREIGN PATENT DOCUMENTS											
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	NO.		JP 9-69541	03-11-1997	NITTO DENKO CORP			JAPAN (w/ English Abstract)			
		JP 10-284648		10-23-1998	HITACHI, LTD	Previously submitted January 31, 2006					
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INITIALS	CITE NO.	journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.									
		Ja	Japanese Office Action issued in corresponding Japanese Patent Application No. JP 2004-086770, dated August 29, 2006								
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.